

IFW



LPD-100
PATENT APPLICATION

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:)
Robert A. Rauch) : Examiner: A. J. Flanigan
 : Group Art Unit: 3753
Application No.: 10/691,171 : Confirmation No.: 6525
Filed: October 22, 2003 :
For: THERMAL INTERFACE :
WAFER AND METHOD OF :
MAKING AND USING SAME : June 20, 2005

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

AMENDMENT

Sir:

In response to the Office Action mailed March 22, 2005
(Part of Paper No./Mail Date 03102005), kindly amend the above-
identified application as follows:

Amendments to the claims appear on page 2 hereof.

An amendment to the Specification appears on page 6
hereof.

Remarks begin on page 8 hereof.